

OPTICS

A dielectric metasurface optical chip for the generation of cold atoms

Lingxiao Zhu^{1,2*}, Xuan Liu^{3,4*}, Basudeb Sain^{5*}, Mengyao Wang^{1*}, Christian Schlickriede⁵, Yutao Tang³, Junhong Deng^{3,4}, Kingfai Li³, Jun Yang², Michael Holynski¹, Shuang Zhang¹, Thomas Zentgraf⁵, Kai Bongs¹, Yu-Hung Lien^{1†}, Guixin Li^{3,4†}

Compact and robust cold atom sources are increasingly important for quantum research, especially for transferring cutting-edge quantum science into practical applications. In this study, we report on a novel scheme that uses a metasurface optical chip to replace the conventional bulky optical elements used to produce a cold atomic ensemble with a single incident laser beam, which is split by the metasurface into multiple beams of the desired polarization states. Atom numbers $\sim 10^7$ and temperatures (about 35 μK) of relevance to quantum sensing are achieved in a compact and robust fashion. Our work highlights the substantial progress toward fully integrated cold atom quantum devices by exploiting metasurface optical chips, which may have great potential in quantum sensing, quantum computing, and other areas.

INTRODUCTION

Quantum systems based on cold atoms have enabled advances in areas such as quantum sensing (1), quantum metrology (2, 3), and quantum simulation (4). These cold atom quantum devices use light to engineer and interrogate the quantum states in accomplishing desired functionalities. The advances in photonic technologies greatly enhance the capabilities of the devices for controlling light and open up new horizons. One of the exciting developments is a metasurface optical device composed of spatially variant subwavelength structures, also called meta-atoms. They offer the capabilities of controlling the amplitude, polarization, and phase of light waves (5–8). Because of the versatility in the field of applications and design flexibility as well as straightforward fabrication methodology, metasurface-based optics can potentially replace or complement their conventional refractive and diffractive counterparts. The two-dimensional nature of metasurfaces opens the door of planar optics, and many innovative planar optical elements have emerged, ranging from linear to nonlinear optics, such as metalens (9, 10), optical holograms (11, 12), vortex beam generation (13), pulse shaping (14), and nonlinear optical phase and wavefront controlling (15, 16). Recently, a number of studies demonstrated that metasurfaces have an enormous potential in quantum optics applications, such as the quantum metasurface interferometer and quantum entanglement states generation and reconstruction (17–19). To the best of our knowledge, metasurfaces have never been used to generate or manipulate cold atomic ensembles, which represents a highly resourceful quantum technology platform. Here, we demonstrate a metasurface optical chip for the generation of cold atomic ensembles, providing a novel scheme for the realization of a single-beam magneto-optical trap (MOT).

Cold atom quantum devices require preparation of cold atomic ensembles using laser cooling and trapping techniques for subsequent operation. Hot gas-phase atoms can be typically cooled and trapped using magneto-optical trapping, which combines laser cooling with a position-dependent restoring force due to radiation pressure (20, 21). The standard MOT apparatus commonly uses three orthogonal pairs of counter-propagating laser beams of appropriate circular polarizations. However, the space-consuming optical systems for delivering the laser beams and the required polarization optics to produce correct circular polarization states are an obstacle for realizing a compact and robust system. Thus, some new variations of the MOT such as pyramid MOT (22), grating MOT (23), and prism MOT (24) have been the most popular choices for fully integrated cold atom quantum experiments and devices. The single-beam geometry of these MOTs greatly strengthens the robustness and stability of the devices by simplifying optical delivery of the laser beams and eliminating relative fluctuations in laser power and polarization between different laser beams, which is a crucial task in a conventional MOT configuration. Despite many advances, these variations compromise between the robustness and the performance as they typically create less symmetric illumination of the capture region for the quantum ensemble leading to deformations in the shape of the cloud (22, 25, 26) and compromise on the efficiency of delivery of the optical power, which is a serious limitation in realizing quantum sensors that meet the demanding size, power, and cost constraints of commercial or space applications.

In this paper, we propose a new metasurface approach to address the above issues. The metasurface is designed to diffract a single incident laser beam into five beams with predefined directions and circular polarization states (Fig. 1). With the assistance of five mirrors, all beams intersect at the center of a quadrupole magnetic field, where the wave vectors of laser beams sum to zero to satisfy the three-dimensional cooling and trapping condition. By using the metasurface optical chip in the MOT system, one can replace the conventional optical systems required for manipulating the laser beam, which are typically composed of large and complex arrays of optical elements such as lenses, prisms, polarization converters, etc.

¹School of Physics and Astronomy, University of Birmingham, Birmingham B15 2TT, UK. ²College of Intelligence Science and Technology, National University of Defense Technology, Changsha 410073, China. ³Department of Materials Science and Engineering, Southern University of Science and Technology, Shenzhen 518055, China. ⁴Shenzhen Institute for Quantum Science and Engineering, Southern University of Science and Technology, Shenzhen 518055, China. ⁵Department of Physics, Paderborn University, Warburger Straße 100, 33098 Paderborn, Germany. *These authors contributed equally to this work.

†Corresponding author. Email: y.lien@bham.ac.uk (Y.-H.L.); ligx@sustech.edu.cn (G.L.)

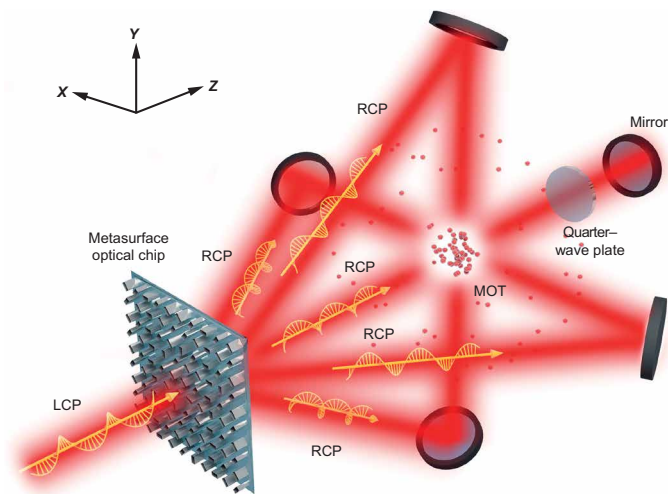


Fig. 1. Schematic of the cold atom device with the dielectric metasurface optical chip. An LCP light passing through the medium is diffracted into five RCP beams, respectively. After the reflection on the mirrors, all the beams are overlapped with the appropriate polarization of the MOT. Atoms are trapped near the zero of a quadrupole magnetic field located within the beam overlapping region. The trapping volume in the metasurface-based MOT has the same shape as that in the six-beam MOT.

RESULTS

Design, fabrication, and characterization of the metasurface optical chip

Here, the dielectric metasurface optical chip is designed on the basis of the concept of the Pancharatnam-Berry (P-B) phase (27–29), also named geometric phase, which only depends on the orientation angle of the anisotropic meta-atoms that act as local half-wave plates. Therefore, the circularly polarized incident light passing through the metasurface is converted into the opposite circular polarization state and acquires a spatially variant phase profile, $\varphi(x, y) = 2\sigma\theta(x, y)$, where $\theta(x, y)$ is the spatial orientation of the meta-atom at position (x, y) and represents the left and right circular polarizations (LCP and RCP, respectively) of the incident light. The detailed design method of the metasurface optical chip is discussed in Materials and Methods. In short, we use amorphous silicon nanofins on a glass substrate as the meta-atoms. The specific geometrical parameters of the meta-atom depicted in Fig. 2A are designed by using numerical simulation software (Finite Difference Time Domain solver, Lumerical Inc.) to maximize the cross-polarization (LCP/RCP to RCP/LCP) conversion efficiency to about 91% at the wavelength of 780 nm (Fig. 2B). The calculated phase profile for generating the desired diffracted beams is shown in Fig. 2C. The scanning electron microscopy (SEM) image of the metasurface optical chip consisting of an array of meta-atoms is shown in Fig. 2D. To prove the concept of metasurface-based MOT, we designed a metasurface optical chip of 599.4 μm by 599.4 μm in size. In principle, it is possible to make metasurface optical chips with inch sizes depending on the experimental requirements.

A detailed characterization of the optical functionalities of the metasurface optical chip is performed using a laser with LCP polarization normally incident on the device. Four beams deflect toward the $\pm x$ axis and the $\pm y$ axis with angles of 22.5° as shown in Fig. 3A. Here, the polarization purity of each first-order diffracted laser beam,

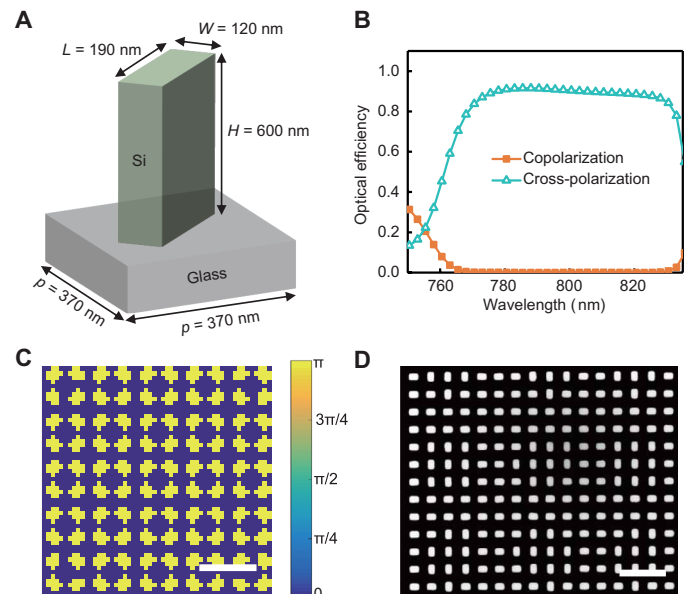


Fig. 2. Design and fabrication of the metasurface optical chip. (A) The geometric configuration of the meta-atom with period $p = 370$ nm, meta-atom length $L = 190$ nm, width $W = 120$ nm, and height $H = 600$ nm. (B) Simulated cross-polarization and copolarization conversion efficiency for different wavelengths of the incident light. (C) The calculated phase profile of the metasurface optical chip. Scale bar, 5 μm . (D) SEM image of the fabricated metasurface optical chip (partial view). Scale bar, 1 μm .

characterized by the RCP percentage, reaches around 99%, as shown in Fig. 3B. For the central beam, its power occupies 83% of the total laser power after transmission, and the RCP percentage is around 6.7%, which means that the central beam has an elliptical polarization. In the following MOT experiment, a circular polarizer will be used to filter out the RCP components. The purity of RCP components of the four laser beams at east (E), west (W), central (C), north (N), and south (S) directions is around 99%, while the power differences between the four beams are within 5% (see the Supplementary Materials). The measured total diffraction efficiency, i.e., the proportion of converting the incident LCP state to the RCP state after the metasurface optical chip, is about 22%, which is far below the theoretically predicted value but can be further improved in the future by optimizing the nanofabrication processes. The measurements show that all the laser beams have a Gaussian profile, which is important to the performance of MOT for generating a symmetrical radiation pressure and cloud distribution (Fig. 3B). Note that the handedness of the four diffracted laser beams is opposite to the one in the center because the field directions of magnetic fields are opposite to each other on the radial and the axial directions (fig. S4D).

Performance of the metasurface-based MOT

The performance of the metasurface-based MOT is characterized by the attainable number and the temperature of trapped atoms. The atom number trapped in the MOT is measured at different laser detuning frequencies and coil currents, as shown in Fig. 4A. Approximately 10^7 atoms are captured by using the optimized parameters, i.e., a detuning of -10 MHz and a coil current of 4.4 A, which produce a magnetic gradient of 16 G/cm. The measured atom number approaches the theoretical limit of $\sim 10^7$, corresponding to the laser diameter of ~ 5 mm and the detuning about 2γ where $\gamma \sim 6$ MHz for

rubidium (30). A higher atom number can be achieved by enlarging the laser beam size and is here limited by the metasurface chip size.

The temperature of an atom cloud can be deduced from the sequential images of free expansion of the cloud after being released from the metasurface MOT when the quadrupole magnetic field is off. The details of the procedures are described in the Supplementary Materials. Figure 4B shows the sequential images of the atom cloud released from the MOT. Figure 4C shows the evolution of the radii of the cloud in the time-of-flight measurement, in which the temporal variation of the cloud size is plotted as the blue trace. Using a

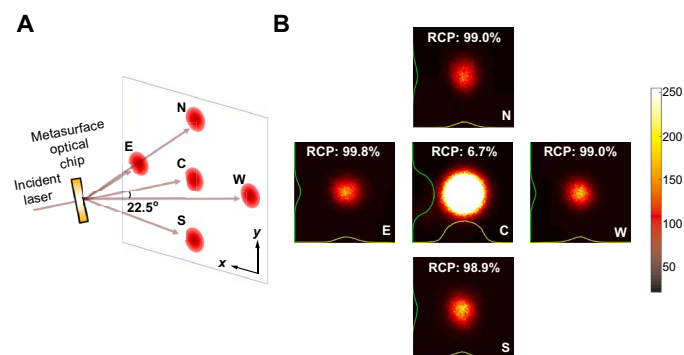


Fig. 3. Measurement of the optical performance of the metasurface optical chip. (A) Schematic of the spatial distribution of the transmitted laser beams after the metasurface optical chip. The laser beams are labeled depending on the location on the projection screen by east (E), west (W), central (C), north (N), and south (S), respectively. (B) Intensity profile of the laser beams captured by a charge-coupled device camera after the metasurface optical chip. The incident laser beams are RCP. All the laser intensity profiles are plotted with the same scale as the color bar. The laser intensity integral along the x and y axis is plotted as the green and yellow curves in each image. The corresponding RCP percentage of each beam is shown on the top of each image.

Gaussian fitting model, the temperature found from the expansion is determined as 764.1 and 2300.0 μK in the axial and radial direction, respectively. Subsequently, three pairs of Helmholtz coils are used to compensate for the ambient magnetic field at the center of the quadrupole magnetic field in the experiment. Then, the magnetic field of the MOT is turned off, and polarization gradient cooling is applied for 10 ms to further cool the atoms to the sub-Doppler temperature. Figure 4D shows that the expansion of the atom cloud after this further cooling step is much slower, corresponding to a temperature of 35.2 and 36.9 μK in the axial and radial direction, respectively. This significant reduction of the temperature can be attributed to the symmetrical and well-balanced radiation pressures generated by the metasurface, which provides a promising candidate for compact cold atom source.

DISCUSSION

In summary, we have provided the first demonstration of the use of metasurface optical chips as a new approach for the generation of cold atoms and assessed their initial performance through realizing initial atom numbers and temperatures commensurate with quantum sensing. We achieve temperatures comparable to what one would get with similar setups and boundary conditions in standard MOT systems. Our experiment does not show any limitations of the temperature imposed by the metasurface technology. Without further optimization, the temperature achieved with the metasurface optical chip is already sufficient for operating compact high-bandwidth atom interferometers and similar to the temperatures used when loading magnetic traps for further evaporative cooling to Bose-Einstein condensation. A pathway to further reductions of temperature, e.g., for applications in atomic fountains, would be by applying optimization techniques similar to those used in standard MOTs for such applications, i.e., optimizing polarization balance, magnetic field

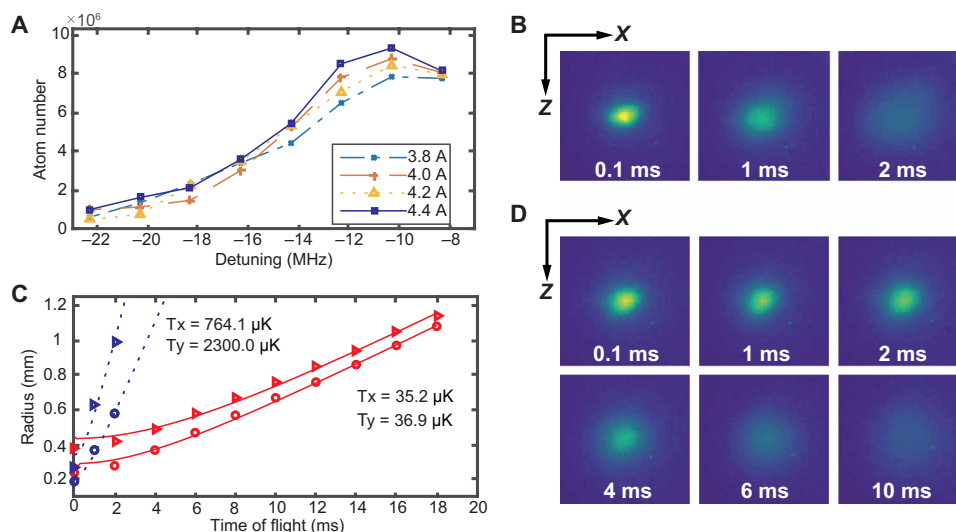


Fig. 4. Performance of the metasurface-based MOT. (A) Variation of the number of atoms trapped in the metasurface-based MOT with the laser detuning. For each curve, a fixed intensity was used. Data points are the average of five runs, resulting in statistical uncertainties much smaller than the plot markers. The atom number peaks at a detuning around 10 MHz below resonance, nearly two linewidths away from the ^{87}Rb transition. The atom number reaches a value close to 10^7 at a coil current of 4.4 A. (B) Absorption images of the ^{87}Rb cloud at expansion times after MOT. (C) The fitted $1/\sqrt{e}$ (68% probability) radii of the ^{87}Rb cloud in the axial (circles) and radial (triangles) directions versus the expansion time. The expansion of the cloud after the MOT (blue) and optical molasses (red) is fitted in dotted and solid curves, respectively. (D) Absorption images of the ^{87}Rb cloud at expansion times after optical molasses.

compensation, and using larger beam diameters. This work provides a new and highly promising approach for the realization of compact and future commercial quantum sensors, particularly through enabling more compact and lower-power systems. Furthermore, it opens a new direction in the application of metasurface for drastically improving the delivery of atom optics or optical lattices, changing the capabilities of a wide range of quantum sensing modalities, and having broad application in quantum metrology, quantum information processing, and atomic physics.

MATERIALS AND METHODS

Design of metasurface optical chip

In principle, the circularly polarized laser normally incident on the metasurface optical chip can be divided into five beams with the same intensity and circular polarizations. One of them propagates along the incident direction, while the other four beams are deflected toward the $\pm x$ axis and the $\pm y$ axis with an angle of 22.5° with respect to the incident beam, respectively. To design the metasurface optical chip, we use a reciprocal process and superpose the five output beams together at the metasurface plane ($z = 0$ plane). In this way, the required phase profile of the P-B phase type metasurface is given by

$$\Phi(x, y) = \arg\left(\sum_{n=0}^4 A_n \cdot e^{-i\mathbf{k}_n \cdot \mathbf{r}_n}\right)$$

where the \arg function returns the argument of the complex amplitude; $n = 0, 1, 2, 3, 4$ represent the five output beams; and A_n is the amplitude of the electric field of light, which is equal to 1 for all n . \mathbf{k}_n and \mathbf{r}_n are the wave vector and position vector of each beam. $|\mathbf{k}_n| = 2\pi/\lambda_0$, where $\lambda_0 = 780$ nm is the wavelength of light in free space. According to the geometrical parameters of the amorphous silicon meta-atom, a metasurface optical chip with a size of $599.4 \mu\text{m}$ by $599.4 \mu\text{m}$ is designed.

Polarization measurement of the laser beams

The setup to measure the polarization of the laser beams after the metasurface optical chip is shown in fig. S3. The linear polarization of the incident laser is improved further by a Glan-Thompson polarizer (extinction ratio = 100,000:1). The laser can be configured in the LCP or RCP by changing the angles of the optical axis between the Glan-Thompson linear polarizer (LP1) and the quarter-wave plate (QWP1). Then, the laser is focused on the metasurface optical chip after passing a lens ($f = 200$ mm). The output after the chip is transmitted through the QWP2 and LP2. By changing the alignment of the optical axis of the QWP2, we can choose the LCP or RCP constituents in the laser passing through the LP2. The results of the measurement are shown in table S1.

MOT apparatus and procedures

The MOT apparatus (fig. S5) comprises a light distribution frame and anti-Helmholtz coils (AHCs) producing the quadrupole magnetic field and a vacuum chamber containing the rubidium atoms. There are three extra pairs of Helmholtz coils installed around the system to compensate for the ambient magnetic field. The distributing frame is made by Plexiglas, and four mirrors are attached on angled mounts to direct the beams. The AHCs are mounted on the rails to align the center of the quadrupole field to the center of the intersection region of optical beams. The coil current of 4.4 A produces a

16 G/cm magnetic field gradient, which is desirable for the operation of the rubidium (Rb) MOT. The main vacuum chamber is an anti-reflection coated glass cell, whose dimensions are 35 mm by 24 mm by 60 mm, and is pumped by a 2 liter/s ion pump. The rubidium atoms are produced by heating a rubidium dispenser with an electric current flowing through. The background pressure is about 2×10^{-9} mbar as the dispenser is cool and raised to 2×10^{-8} mbar when the experiment is running.

SUPPLEMENTARY MATERIALS

Supplementary material for this article is available at <http://advances.sciencemag.org/cgi/content/full/6/31/eabb6667/DC1>

REFERENCES AND NOTES

1. Y. Bidel, N. Zahzam, C. Blanchard, A. Bonnin, M. Cadoret, A. Bresson, D. Rouxel, M. F. Lequentrec-Lalancette, Absolute marine gravimetry with matter-wave interferometry. *Nat. Commun.* **9**, 627 (2018).
2. J. Grotti, S. Koller, S. Vogt, S. Häfner, U. Sterr, C. Lisdat, H. Denker, C. Voigt, L. Timmen, A. Rolland, F. N. Baynes, H. S. Margolis, M. Zampaolo, P. Thoumany, M. Pizzocaro, B. Rauf, F. Bregolin, A. Tampellini, P. Barbieri, M. Zucco, G. A. Costanzo, C. Clivati, F. Levi, D. Calonico, Geodesy and metrology with a transportable optical clock. *Nat. Phys.* **14**, 437–441 (2018).
3. M. Koschorreck, M. Napolitano, B. Dubost, M. W. Mitchell, Sub-projection-noise sensitivity in broadband atomic magnetometry. *Phys. Rev. Lett.* **104**, 093602 (2010).
4. I. M. Georgescu, S. Ashhab, F. Nori, Quantum simulation. *Rev. Mod. Phys.* **86**, 153–185 (2014).
5. A. V. Kildishev, A. Boltasseva, V. M. Shalaev, Planar photonics with metasurfaces. *Science* **339**, 1232009 (2013).
6. Y. Kivshar, All-dielectric meta-optics and non-linear nanophotonics. *Natl. Sci. Rev.* **5**, 144–158 (2018).
7. N. Yu, F. Capasso, Flat optics with designer metasurfaces. *Nat. Mater.* **13**, 139–150 (2014).
8. D. Lin, P. Fan, E. Hasman, M. L. Brongersma, Dielectric gradient metasurface optical elements. *Science* **345**, 298–302 (2014).
9. S. Wang, P. C. Wu, V.-C. Su, Y.-C. Lai, M.-K. Chen, H. Y. Kuo, B. H. Chen, Y. H. Chen, T.-T. Huang, J.-H. Wang, R.-M. Lin, C.-H. Kuan, T. Li, Z. Wang, S. Zhu, D. P. Tsai, A broadband achromatic metalens in the visible. *Nat. Nanotechnol.* **13**, 227–232 (2018).
10. W. T. Chen, A. Y. Zhu, V. Sanjeev, M. Khorasaninejad, Z. Shi, E. Lee, F. Capasso, A broadband achromatic metalens for focusing and imaging in the visible. *Nat. Nanotechnol.* **13**, 220–226 (2018).
11. G. Zheng, H. Mühlenbernd, M. Kenney, G. Li, T. Zentgraf, S. Zhang, Metasurface holograms reaching 80% efficiency. *Nat. Nanotechnol.* **10**, 308–312 (2015).
12. A. Arbabi, Y. Horie, M. Bagheri, A. Faraon, Dielectric metasurfaces for complete control of phase and polarization with subwavelength spatial resolution and high transmission. *Nat. Nanotechnol.* **10**, 937–943 (2015).
13. R. C. Devlin, A. Ambrosio, N. A. Rubin, J. P. B. Mueller, F. Capasso, Arbitrary spin-to-orbital angular momentum conversion of light. *Science* **358**, 896–901 (2017).
14. S. Divitt, W. Zhu, C. Zhang, H. J. Lezec, A. Agrawal, Ultrafast optical pulse shaping using dielectric metasurfaces. *Science* **364**, 890–894 (2019).
15. G. Li, S. Chen, N. Pholchai, B. Reineke, P. Wing, H. Wong, E. Yue, B. Pun, K. W. Cheah, T. Zentgraf, S. Zhang, Continuous control of the nonlinearity phase for harmonic generations. *Nat. Mater.* **14**, 607–612 (2015).
16. G. Li, S. Zhang, T. Zentgraf, Nonlinear photonic metasurfaces. *Nat. Rev. Mater.* **2**, 17010 (2017).
17. K. Wang, J. G. Titchener, S. S. Kruk, L. Xu, H.-P. Chung, M. Parry, I. I. Kravchenko, Y.-H. Chen, A. S. Solntsev, Y. S. Kivshar, D. N. Neshev, A. A. Sukhorukov, Quantum metasurface for multiphoton interference and state reconstruction. *Science* **361**, 1104–1108 (2018).
18. T. Stav, A. Faerman, E. Maguid, D. Oren, V. Kleiner, E. Hasman, M. Segev, Quantum entanglement of the spin and orbital angular momentum of photons using metamaterials. *Science* **361**, 1101–1104 (2018).
19. P. Georgi, M. Massaro, K.-H. Luo, B. Sain, N. Montaut, H. Herrmann, T. Weiss, G. Li, C. Silberhorn, T. Zentgraf, Metasurface interferometry toward quantum sensors. *Light Sci. Appl.* **8**, 70 (2019).
20. S. Chu, L. Hollberg, J. E. Bjorkholm, A. Cable, A. Ashkin, Three-dimensional viscous confinement and cooling of atoms by resonance radiation pressure. *Phys. Rev. Lett.* **55**, 48–51 (1985).
21. W. D. Phillips, A. L. Migdall, H. J. Metcalf, Laser-cooling and electromagnetic trapping of neutral atoms. *AIP Conf. Proc.* **146**, 362–365 (1986).
22. S. Pollock, J. P. Cotter, A. Laliotis, F. Ramirez-Martinez, E. A. Hinds, Characteristics of integrated magneto-optical traps for atom chips. *New J. Phys.* **13**, 043029 (2011).

23. C. C. Nshii, M. Vangeleyn, J. P. Cotter, P. F. Griffin, E. A. Hinds, C. N. Ironside, P. See, A. G. Sinclair, E. Riis, A. S. Arnold, A surface-patterned chip as a strong source of ultracold atoms for quantum technologies. *Nat. Nanotechnol.* **8**, 321–324 (2013).
24. A. Hinton, M. Perea-Ortiz, J. Winch, J. Briggs, S. Freer, D. Moustoukas, S. Powell-Gill, C. Squire, A. Lamb, C. Rammeloo, B. Stray, G. Voulazeris, L. Zhu, A. Kaushik, Y.-H. Lien, A. Niggebaum, A. Rodgers, A. Stabrawa, D. Boddice, S. R. Plant, G. W. Tuckwell, K. Bongs, N. Metje, M. Holynski, A portable magneto-optical trap with prospects for atom interferometry in civil engineering. *Philos. Trans. R. Soc. A Math. Phys. Eng. Sci.* **375**, 20160238 (2017).
25. J. P. McGilligan, P. F. Griffin, E. Riis, A. S. Arnold, Phase-space properties of magneto-optical traps utilising micro-fabricated gratings. *Opt. Express* **23**, 8948–8959 (2015).
26. J. Lee, J. A. Grover, L. A. Orozco, S. L. Rolston, Sub-doppler cooling of neutral atoms in a grating magneto-optical trap. *J. Opt. Soc. Am. B.* **30**, 2869–2874 (2013).
27. M. V. Berry, The Adiabatic phase and Pancharatnam's phase for polarized light. *J. Mod. Opt.* **34**, 1401–1407 (1987).
28. S. Pancharatnam, Generalized theory of interference and its applications. *Proc. Indian Acad. Sci. Sect. A.* **44**, 398–417 (1956).
29. Z. Bomzon, G. Biener, V. Kleiner, E. Hasman, Space-variant Pancharatnam–Berry phase optical elements with computer-generated subwavelength gratings. *Opt. Lett.* **27**, 1141–1143 (2002).
30. G. W. Hoth, E. A. Donley, J. Kitching, Atom number in magneto-optic traps with millimeter scale laser beams. *Opt. Lett.* **38**, 661–663 (2013).
31. C. J. Foot, *Atomic Physics* (Oxford Univ. Press, 2005).
32. D. A. Steck, *Rubidium 87 D Line Data* (21 November 2019); <https://steck.us/alkalidata/rubidium87numbers.pdf>.

Acknowledgments: We thank the fruitful discussions with X. Li, L. Huang, and J. Rho at the early stage of this project. L.Z. thanks H. Zhang and X. Zhang for preparing the figures. **Funding:** G.L.

was financially supported by the National Natural Science Foundation of China (91950114 and 11774145), the Guangdong Provincial Innovation and Entrepreneurship Project (2017ZT07C071), the Shenzhen DRC project [2018]1433, and the Qiu Shi Science & Technologies Foundation. M.W., Y.-H.L., M.H., and K.B. were supported by the Engineering and Physical Sciences Research Council (EPSRC, EP/M013294/1 and EP/T001046/1). T.Z. and S.Z. acknowledge the funding from the European Research Council (ERC) under the European Union's Horizon 2020 research and innovation programme (grant agreement No. 724306 and No. 648783). L.Z. was supported by the Young Elite Scientists Sponsorship Program by CAST (2018QNRC001). **Author contributions:** G.L., Y.-H.L., and L.Z. conceived the idea. X.L. and G.L. carried out the simulations. B.S., C.S., and T.Z. fabricated the metasurface. L.Z., K.L., Y.T., and J.D. measured the polarization states of the metasurface optical chip. Y.-H.L. and M.W. conducted the measurement of performance of the cold atom device. M.H. and K.B. contributed to the scientific discussion and the implementation of the cold atom device. Y.-H.L. and G.L. supervised the project. All authors contributed to the data analysis and manuscript writing. **Competing interests:** The authors declare that they have no competing interests. **Data and materials availability:** All data needed to evaluate the conclusions in the paper are present in the paper and/or the Supplementary Materials. Additional data related to this paper may be requested from the authors.

Submitted 10 March 2020

Accepted 12 June 2020

Published 29 July 2020

10.1126/sciadv.abb6667

Citation: L. Zhu, X. Liu, B. Sain, M. Wang, C. Schlickriede, Y. Tang, J. Deng, K. Li, J. Yang, M. Holynski, S. Zhang, T. Zentgraf, K. Bongs, Y.-H. Lien, G. Li, A dielectric metasurface optical chip for the generation of cold atoms. *Sci. Adv.* **6**, eabb6667 (2020).

A dielectric metasurface optical chip for the generation of cold atoms

Lingxiao Zhu, Xuan Liu, Basudeb Sain, Mengyao Wang, Christian Schlickriede, Yutao Tang, Junhong Deng, Kingfai Li, Jun Yang, Michael Holynski, Shuang Zhang, Thomas Zentgraf, Kai Bongs, Yu-Hung Lien and Guixin Li

Sci Adv **6** (31), eabb6667.
DOI: 10.1126/sciadv.abb6667

ARTICLE TOOLS

<http://advances.sciencemag.org/content/6/31/eabb6667>

SUPPLEMENTARY MATERIALS

<http://advances.sciencemag.org/content/suppl/2020/07/27/6.31.eabb6667.DC1>

REFERENCES

This article cites 30 articles, 6 of which you can access for free
<http://advances.sciencemag.org/content/6/31/eabb6667#BIBL>

PERMISSIONS

<http://www.sciencemag.org/help/reprints-and-permissions>

Use of this article is subject to the [Terms of Service](#)

Science Advances (ISSN 2375-2548) is published by the American Association for the Advancement of Science, 1200 New York Avenue NW, Washington, DC 20005. The title *Science Advances* is a registered trademark of AAAS.

Copyright © 2020 The Authors, some rights reserved; exclusive licensee American Association for the Advancement of Science. No claim to original U.S. Government Works. Distributed under a Creative Commons Attribution NonCommercial License 4.0 (CC BY-NC).